

Docket No. 246408US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Eiju KOMURO, et al.

SERIAL NO: New Application

GAU:

FILED: Herewith

EXAMINER:

FOR: PIEZOELECTRIC RESONANT FILTER AND DUPLEXER

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

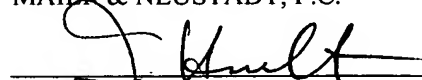
- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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DOCKET NO: 246408US2

Sheet 1 of 1

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STATEMENT OF RELEVANCY

References AO (JP 58-137317), AP (JP 58-153412), AQ (JP 60-189307), AR (JP 60-68711), AS (JP 59-141813), AT (JP 60-171822), AU (JP 9-64683), AV (JP 2001-502136), and AW on Form PTO- 1449:

These references are discussed in the specification.

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY DOCKET NO.
246408US2SERIAL NO.
New Application

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT
Eiju KOMURO, et al.FILING DATE
Herewith

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO	58-137317	08/15/83	Japan		x
	AP	58-153412	09/12/83	Japan		x
	AQ	60-189307	09/26/85	Japan		x
	AR	60-68711	04/19/85	Japan		x
	AS	59-141813	08/14/84	Japan		x
	AT	60-171822	09/05/85	Japan		x
	AU	9-64683	03/07/97	Japan		x
	AV	2001-502136	02/13/01	Japan		x

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW	Kiyoshi NAKAMURA, et al., "Thin Film Resonators and Filter", INTERNATIONAL SYMPOSIUM ON ACOUSTIC WAVE DEVICES FOR FUTURE MOBILE COMMUNICATION SYSTEMS, COLLECTED PAPERS, March 5-7, 2001, pgs. 93-99				
	AX					
	AY					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached

Examiner

Date Considered

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.